



IPW

Docket No.: 60188-693

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Yoshiyuki SHIBATA : Confirmation Number: 4097
Serial No.: 10/694,891 : Group Art Unit: 2812
Filed: October 29, 2003 : Examiner: Jennifer M. KENNEDY
For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of April 20, 2004 wherein restriction has been required, Applicant(s) hereby elect First Embodiment, Group I, corresponding to Figs. 2, 3A-3D and 4A-4B (claims 1-7, drawn to a semiconductor device) for prosecution in the above-identified application. Furthermore, Applicants identify claim 3 as reading on the elected species.

To the extent necessary, a petition for an extension of time under 37 C.F.R. § 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


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